

**Notice of References Cited**

Application/Control No.

10/529,634

Applicant(s)/Patent Under  
Reexamination  
QIAN ET AL.

Examiner

Sun Jae Y. Loewe

Art Unit

1626

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Gehlen et al., caplus an 1962:16892
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